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J1003 U.S. PTO

UTILITY PATENT APPLICATION

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Washington D.C. 20231

Docket No. 3008-34
Client No. PHCF-01103

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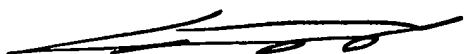
Sir:

Transmitted herewith for filing is the patent application of:
INVENTOR(S): Fumihito Oka, Shinichi Muramatsu and Yasushi Minagawa
FOR: CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE,
CRYSTALLINE SILICON THIN FILM PHOTOVOLTAIC DEVICE, AND PROCESS
FOR PRODUCING CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR
DEVICE

Enclosed are:

- ☒ 33 pages of specification, claims, abstract
- ☐ Declaration & Power of Attorney.
- ☐ Priority Claimed
- ☒ 3 sheets of drawing(s).
- ☐ An assignment of the invention to _____
and the assignment recordation fee.
- ☐ Certified copy of _____
- ☐ An associate power of attorney.
- ☐ Information Disclosure Statement, Form PTO-1449 and reference.
- ☐ I hereby certify that the invention disclosed in the attached
application has not and is not presently intended to be the
subject of an application filed in another country, or under a
multilateral agreement, that requires publication at eighteen
months after filing. I hereby request that the attached
application not be published under 35 USC § 122(b).

LALOS & KEEGAN



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